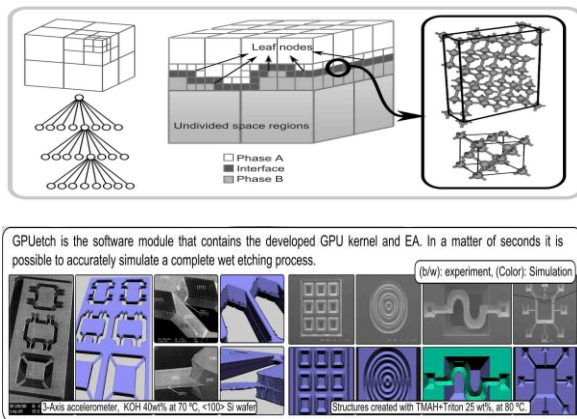


NNIN/C Modeling & Simulation Contest Winners

1st Prize

GPUetch: A Fast and Accurate Wet Etching Simulator for Silicon and Quartz MEMS



Néstor Ferrando, University of Valencia

2nd Prize

Open Source Simulation Tool for Non Linear Electrophoretic Processes

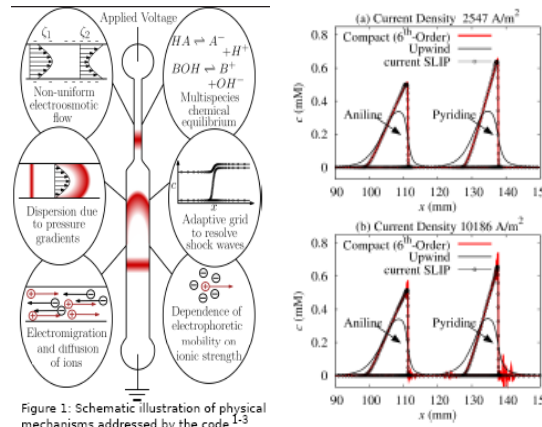
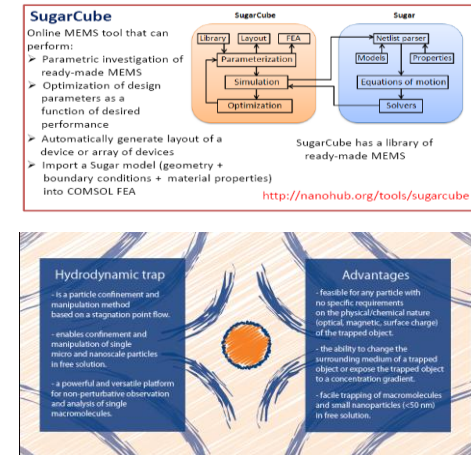


Figure 1: Schematic illustration of physical mechanisms addressed by the code.¹⁻³

Supreet S. Bahga, Stanford University

3rd Prize

Hydrodynamic Trap & Advances in CAD for MEMS



Melikhhan Tanyeri, University of Illinois, Urbana-Champaign
&
Prabhakar Marepalli, Purdue University